

FORM PTO-1449 SAMUELS, GAUTHIER & STEVENS LLP  
(Rev. 5/92) 225 Franklin Street, Boston, MA 02110  
Telephone: (617) 426-9180

**5780**  
ATTORNEY DOCKET NO.

**09/661,766**  
SERIAL NO.

Gormley et al.  
APPLICANT

2811  
GROUP

09/14/2000  
FILING DATE

VU, Quang D  
EXAMINER

**INFORMATION DISCLOSURE  
STATEMENT BY APPLICANT**

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
qv	AA	6,064,081	05/16/2000	Robinson et al.			01/15/1998
qv	AB	5,760,443	06/02/1998	McCarthy			10/23/1995
qv	AC	5,629,790	05/13/1997	Neukermans et al.			10/18/1993
qv	AD	4,614,119	09/30/1986	Zavracky et al.			03/08/19985
	AE						
	AF						

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
qv	AG	2,275,787	09/07/1994	UK			YES
	AH						
	AI						

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

EXAMINER INITIAL		
qv	AJ	"Evaluation of Wafer Bonding and Etch Back for SOI Technology," Baumgart et al. <i>Philips Journal of Research</i> . 1995. Vol. 49, No. 1/2.
qv	AK	"Micromachined Widely Tunable Vertical Cavity Laser Diodes," Sugihwo et al. <i>Journal of Microelectromechanical Systems</i> . March 1998. Vol. 7, No. 1.
	AL	
	AM	
	AN	
	AO	

EXAMINER

DATE CONSIDERED 07/28/03

**EXAMINER:**

Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

RECEIVED  
HALL-5 2003  
TECHNOLOGY CENTER 2800